## Sulfosorb® Gas Purification Systems | spectro mol



Sulfosorb® gas purification systems are designed for the removal of sulphur compounds and other impurities from gas flows.

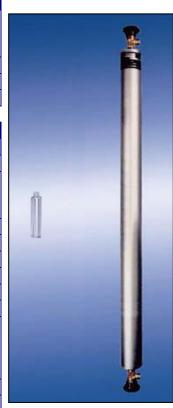
The applied process is chemisorptions.

<u>Chemisorptions:</u> sulphur compounds and other impurities (e.g. mercaptan, carbonyl sulphide, carbon-disulphide, hydrogen sulphide, sulphur dioxide and nitrogen monoxide) are chemically bound to a porous absorber material and therefore permanently removed from the gas flow.

For Sulfosorb® gas purification systems, activated carbon Type C is used as absorber material.

Sulfosorb <sup>®</sup>		
Applicable for	Rare gases, N <sub>2</sub> , H <sub>2</sub> , CO, CO <sub>2</sub> , saturated/non-saturated HC and compresse air	
Removed contaminants	Mercaptan, COS, CS <sub>2</sub> , H <sub>2</sub> S, SO <sub>2</sub> , NO	
Process	chemisorptions	
Final purity	H2S and NO < 1 ppm	

Sulfosorb <sup>®</sup>		
	Small cartridge	Large cartridge
Shield gas	Helium	Argon
Capacity	SO <sub>2</sub> : 500 mg	SO₂: 28 g
	H₂S: 500 mg	H₂S: 28 g
	NO: 50 mg	NO: 2,8 g
Optical indication	no	no
Max. gas flow	1 m <sup>3</sup> /h	10 m³/h
Max. working pressure	10 bar <sup>1)</sup>	
Length	125 mm	1.170 mm
Diameter	29 mm	71 mm
Material	Aluminium	Aluminium
Remarks	-	Complete with
		2 diaphragm type
		valves
		Connections: NPTF 1/4"
Delivery	2-pack	single
Part no.	123328	123350



<sup>1)</sup> Small cartridges can be applied with high pressure housing PN200 for working pressure up to 200 bar.

For removal of moisture:

For removal of HC and oil vapour:

see price list Hydrosorb®
see price list Accosorb®

For removal of Fluoride see price list Excisorb®-F

For holders, purge systems and accessories: see price list Spectromol accessories